Sirenko Vladimir S. Course Schedule

WEDNESDAY

12:45 — 13:30	■ LEC Thermal fields in the device engineering, thermal exposure and testing 📽 M19-601 💡 ДОТ
13:35 — 16:05	■ SEM Thermal fields in the device engineering, thermal exposure and testing 📽 M19-601 💡 ДОТ